



EcoSys CD0863 The Industry Standard for Thermal-Wet Treatment

he CDO[™] series is an advanced point–of–use integrated thermal–wet treatment system designed to provide a controlled gas conditioning environment for today's demanding semiconductor process chemistries. The CDO series is the industry standard for controlled decomposition–oxidation treatment of flammable, pyrophoric, corrosive, and particulate generating process recipes.

The CDO 863 was specifically designed to treat fluorine generated by plasma chamber clean applications without the use of fuel or toxic reagents. Constructed with advanced metal alloys for corrosion resistance, the CDO 863 is the safest, most cost–effective abatement system for the treatment of F_2 at the point–of–use ensuring customers the highest reliability and tool uptime.

The patented water reagent technology incorporated in the CDO 863 combined with the latest advancements in system reliability provide the lowest cost of ownership for treating fluorine-based effluent.







Applications

Flourine-based process chamber cleans

Advantages

- Designed for point-of-use fluorine abatement without fuel or toxic reagents
- Will treat incompatible gases from multiple process outlets
- Reduced water consumption with recirculating water system
- Non–clogging entry design
- Lowest cost of ownership
- Advanced alloys for improved corrosion resistance
- Ease of installation with standard pressurized drain
- Moisture suppression system reduces downstream condensation
- Semi S2 and CE compliant

Configurations

- Number of inlets (1–4)
- Fire retardant tank material FM4910

Tool Communication and Interlocks

Multiple dry contacts for customer defined requirements

Options and Accessories

- Remote indication box
- De-ionized water generator



EcoSys CD0863

Specifications

Performance Specifications

Process Flow	1–4 inlets	
Per Inlet	100 slm (3.5 scfm) max	
Per System	200 slm (7.1 scfm) max	
 Fresh Water Consumption 	0.3 gpm (1.4 Lpm) min	
 Chilled Water Consumption 	5 gpm (18.9 Lpm)	
 Nitrogen Consumption 	43 slm (1.5 scfm)	
 CDA Consumption 		
w/o moisture suppression	80 slm (2.8 scfm)	
with moisture suppression	240 slm (8.5 scfm)	
 Process Exhaust 		
Static Pressure	-5" to 0.5" w.c. (-1.2 to 0.12 kPA)	
Exhaust Flow	566 slm (20 cfm)	
 Electrical Consumption 	5,600 watts	
 Reliability 		
MTBF	> 4,300 hours	
MTTR	4 hours	

Dimensions



Item	Dimension	Item	Dimension	Item	Dimension
1	2" (5.08cm)	9	18.75" (48cm)	17	10.5" (26cm)
2	12.75" (32cm)	10	58" (147cm)	18	15" (38cm)
3	3" (8cm)	11	41" (104cm)	19	18" (45cm)
4	11.75" (30cm)	12	48" (122cm)	20	19.5" (49cm)
5	9.25" (23cm)	13	39" (104cm)	21	25" (62cm)
6	5.5" (14cm)	14	30" (76cm)	22	31.75" (81cm)
7	7.75" (20cm)	15	15" (38cm)		
8	11.75" (30cm)	16	7.5" (19cm)		

Facilities Specifications

 Process Connections 	1–4 inlets
	KF–40, type 1
 Nitrogen Gas source 	70–100 psi (4.8–6.9 bar)
	3/8″ compression fitting
 Clean Dry Air source 	80–100 psi (5.5–6.9 bar)
	1/2" compression fitting
 Fresh Water 	45–75 psi (3.1–5.2 bar)
	1/2″ female NPT
 De-ionized Water 	13–17 psi (0.9–1.2 bar)
	1/4″ compression fitting
 Chilled Water Inlet 	20–60 psi (1.4–4.1 bar)
	50 °F (10 °C)
 Chilled Water Inlet/Outlet 	1″ female NPT
 Sump Pump Drain 	1/2″ female NPT
 Enclosure Exhaust 	6″ (152 mm) SS or FRP
 Process Exhaust 	ISO 4″ x (100 mm)
 Electrical Supply 	208/220 VAC, 50/60 Hz, 40 A, 3 or 4-wire
 Overall Dimensions 	77 H x 48 W x 41 D in (1,956 x 1,219 x 1,041 mm)
Clearance	
Front	36 in (914 mm)
Right/Left/Rear	12 in (305 mm)
 Weight 	
Shipping	602 lbs (223 kg)
Installed	830 lbs (375 kg)

System Diagram





EcoSys 655 River Oaks Parkway, San Jose CA 95134 USA Phone: 1.408.526.9400 Fax: 1.408.933.6502 EcoSys is a division of Metron Technology.